5-25-05

Signature Date

- PTQ/SB/21 (03-03)

Approved for use through 04/30/2003. OMB 0651-0031 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE der the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. Application Number 10/656,732 **TRANSMITTAL** Filing Date September 4, 2003 **FORM** First Named Inventor Manning Art Unit 2811 (to be used for all correspondence after initial filing) **Examiner Name** J. Fenty Attorney Docket Number MI22-2608 Total Number of Pages in This Submission **ENCLOSURES** (Check all that apply) After Allowance Communication Fee Transmittal Form Drawing(s) to a Technology Center (TC) Appeal Communication to Board Licensing-related Papers Fee Attached of Appeals and Interferences Appeal Communication to TC Petition (Appeal Notice, Brief, Reply Brief) Amendment/Reply Petition to Convert to a Proprietary Information After Final **Provisional Application** Power of Attorney, Revocation Status Letter Affidavits/declaration(s) Change of Correspondence Address Other Enclosure(s) (please Terminal Disclaimer Extension of Time Request Identify below): Form PTO-1449; Return Receipt Request for Refund **Express Abandonment Request** Postcard; Cited References(10) CD. Number of CD(s) Information Disclosure Statement Remarks Certified Copy of Priority Additional Enclosure: **EV55**0717217 Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53 SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Firm David G. Latwesen Ph.D., Reg. No. 38,533 Wells St. John, P.S. Individual

CERTIFICATE OF TRANSMISSION/MAILING  I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient process and in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on this date:  5-24-65	
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This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

PTO/SB/17 (12-04v2) Approved for use through 07/31/2006. OMB 0651-0032 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Complete if Known Effective on 12/08/2004. to the Consolidated Appropriations Act, 2005 (H.R. 4818). 10/656,732 **Application Number** TRANSMITTA Filing Date 9/4/2003 For FY 2005 First Named Inventor Manning **Examiner Name** J. Fenty Applicant claims small entity status. See 37 CFR 1.27 Art Unit 2811 TOTAL AMOUNT OF PAYMENT 180.00 MI22-2608 Attomey Docket No. METHOD OF PAYMENT (check all that apply) Check Credit Card Money Order None Other (please identify): Deposit Account Name: Wells St. John, P.S. Deposit Account Deposit Account Number: 23-0925 For the above-identified deposit account, the Director is hereby authorized to: (check all that apply) Charge fee(s) indicated below Charge fee(s) indicated below, except for the filing fee Charge any additional fee(s) or underpayments of fee(s) Credit any overpayments under 37 CFR 1.16 and 1.17 WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. **FEE CALCULATION** 1. BASIC FILING, SEARCH, AND EXAMINATION FEES **FILING FEES SEARCH FEES EXAMINATION FEES Small Entity Small Entity** Small Entity Fees Paid (\$) **Application Type** Fee (\$) Fee (\$) Fee (\$) Fee (\$) Fee (\$) Fee (\$) 300 Utility 150 500 200 100 250 Design 200 100 100 50 130 65 Plant 200 100 300 160 150 80 300 500 600 Reissue 150 300 250 Provisional 200 100 0 **Small Entity** 2. EXCESS CLAIM FEES Fee (\$) Fee Description Fee (\$) Each claim over 20 (including Reissus) 50 25 200 Each independent claim over 3 (including Reissues) 100 Multiple dependent claims 360 180 Total Claims Fee (\$) Fee Paid (\$) Multiple Dependent Claims - 20 or HP = Fee Paid (\$) Fee (\$) HP = highest number of total claims paid for, if greater than 20. Fee (\$) Indep. Claims **Extra Claims** Fee Paid (\$) - 3 or HP = HP = highest number of independent claims paid for, if greater than 3. If the specification and drawings exceed 100 sheets of paper (excluding electronically filed sequence or computer listings under 37 CFR 1.52(e)), the application size fee due is \$250 (\$125 for small entity) for each additional 50 sheets or fraction thereof. See 35 U.S.C. 41(a)(1)(G) and 37 CFR 1.16(s). Number of each additional 50 or fraction thereof Extra Sheets **Total Sheets** Fee (\$) Fee Paid (\$) (round up to a whole number) x

SUBMITTED BY	1)		
Signature	4	Registration No. (Attorney/Agent) 38,533	Telephone 509-624-4276
Name (Print/Type	) David G. Latwesen, Ph.D.		Date 5/7/65

Non-English Specification, \$130 fee (no small entity discount)

Other (e.g., late filing surcharge): Supplemental Information Disclosure Statement

Fees Paid (\$)

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4. OTHER FEE(S)

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### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	10/656,732
Confirmation No	4772
Filing Date	September 4, 2003
Inventor	H. Montgomery Manning
Assignee	Micron Technology, Inc.
	2811
Examiner	J. Fenty
Attorney's Docket No	MI22-2608
Customer No	
Title: Support For Vertically Oriented Capac	citors During the Formation of a Semiconductor
Device	•

### SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art. EV550717217

Datad:

Respectfully submitted,

By:

David G. Latwesen, Ph.D.

Reg. No. 38,533

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#### Form PTO-1449

# U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY.	DOCKET	NO.
MI22-2	608	

APPLICANT: H. Montgomery Manning

SERIAL NO. 10/656,732

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FILING DATE

September 4, 2003

GROUP 2811

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U.S. PATEN	U.S. PATENT DOCUMENTS									
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate			
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FOREIGN F	ATENT	DOCUMENTS						
		Document	Date	Country	Class	Subclass	Transla	tion
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	AD	DE 4447804	1/2002	Germany 550 /	ا کے ا		Abstract	÷
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		IEEE J. SELECTED TOPICS IN QUANTUM ELECTR., Vol. 8, No. 5, pp. 998-1008 (Sept/Oct 2002).
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		No. 19, pp. 2770-2772 (November 1997).
EXAMINER		DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449

# U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. MI22-2608

SERIAL NO. 10/656,732

LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)

APPLICANT: H. Montgomery Manning

FILING DATE September 4, 2003

**GROUP** 2811

*Examiner's Initials		Document Number	<sup>*</sup> Date Name	Name	Class	Subclass	Filing Date If Appropriate		
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